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APPLICANTS

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** CONTINUING DATA *****
 THM None

** FOREIGN APPLICATIONS *****
 THM None

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 10/28/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials _____	STATE OR COUNTRY TAIWAN	SHEETS DRAWING 4	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 3
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 21552
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TITLE
 Method for improving film uniformity in plasma enhanced chemical vapor deposition system

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